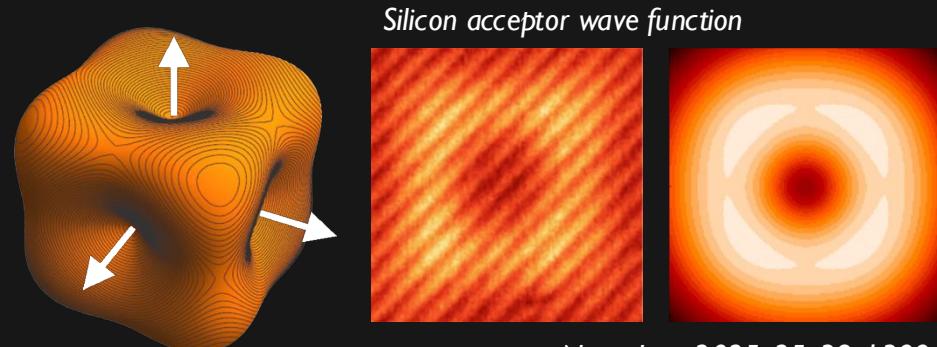


Imaging and Understanding Quantum States in Semiconductors and 2D Materials

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 schofield-lab.github.io



Nano Lett. 2025, 25, 38, 13996

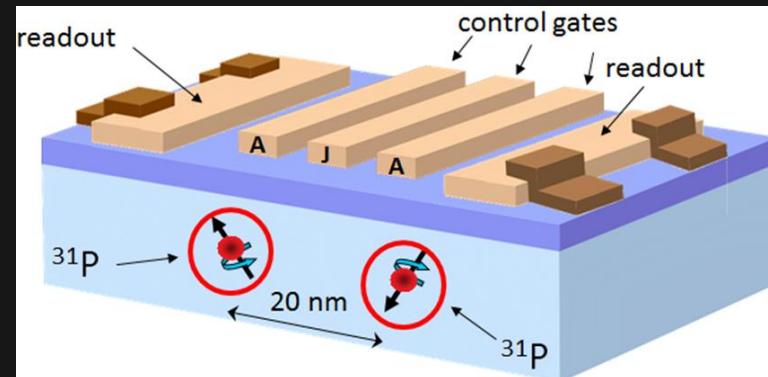
PhD studentships available, including: "Mapping the Quantum Landscape of 2D Materials, One Atom at a Time"

Deterministically positioned defects → scalable quantum technologies

- Single dopant atoms can be positioned deterministically in semiconductors using STM
- Enabling atomically-precise quantum devices
- Scaling to many dopants is essential for qubit arrays and quantum architectures

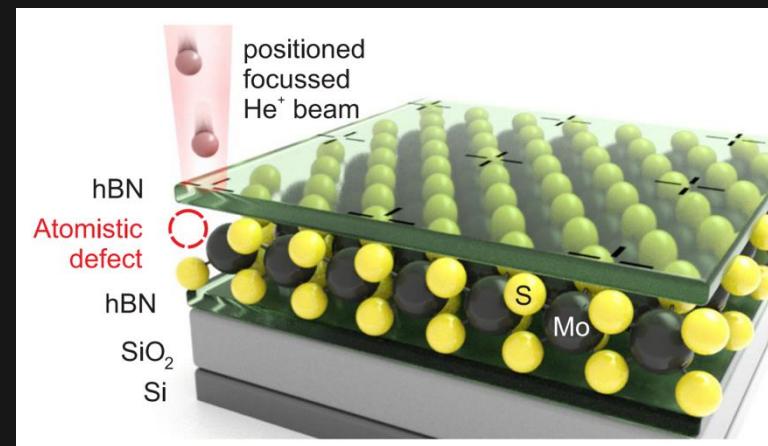
See also: *Roadmap on atomic-scale semiconductor devices*,
Schofield et al., *Nano Futures* 9 012001 (2025)

Single Dopant Atoms in Si as Qubits



Kane, Nature 393 133 (1998)

Atomically Precise Positioning Defects in MoS₂



Nano Letters, 20, 4437 (2020)

Fabrication to Understanding: Exploring the Foundations of Atomic-Scale Devices

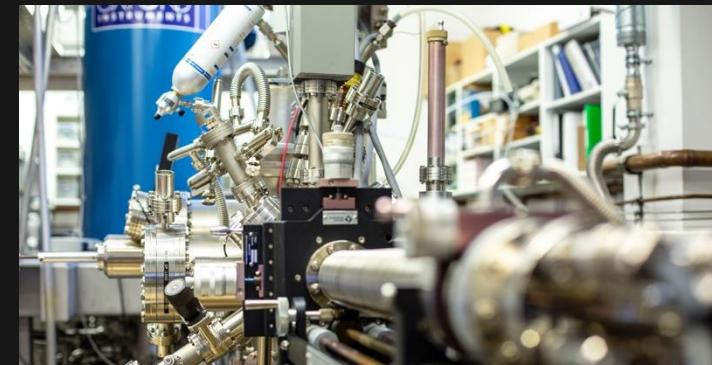
We study atomic-scale quantum phenomena, helping to build the scientific foundation for future atomic-scale device concepts:

- Surface chemistry and adsorption studied using STM
- Surface and sub-surface defect and dopant states probed using tunnelling spectroscopy
- Band and valley structure characterised with ARPES
- EUV-surface interactions to understand → atomic-scale patterning mechanisms
- Electronic structure and defect wave functions modelled computationally (in-house and with collaborators)

Constantinou et al.,
Nature Commun.
15, 694 (2024)

Tseng, et al., Science
Advances 9, eadf5997
(2023)

Cryogenic Scanning Tunnelling Microscopy



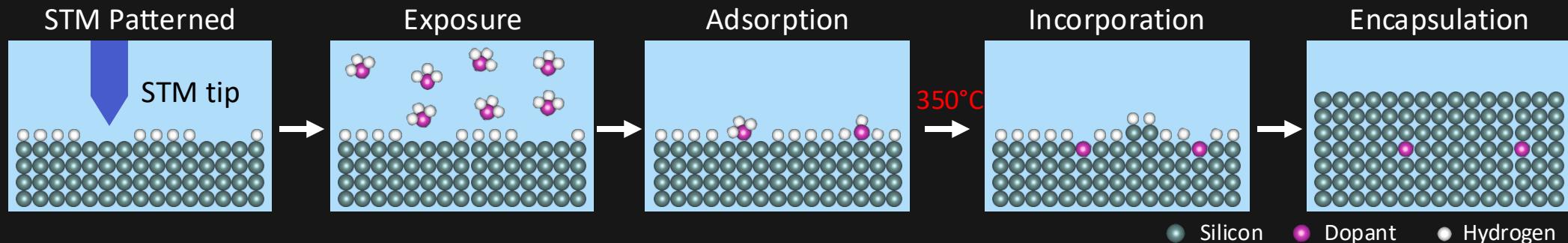
Synchrotron (ARPES, EUV Patterning)



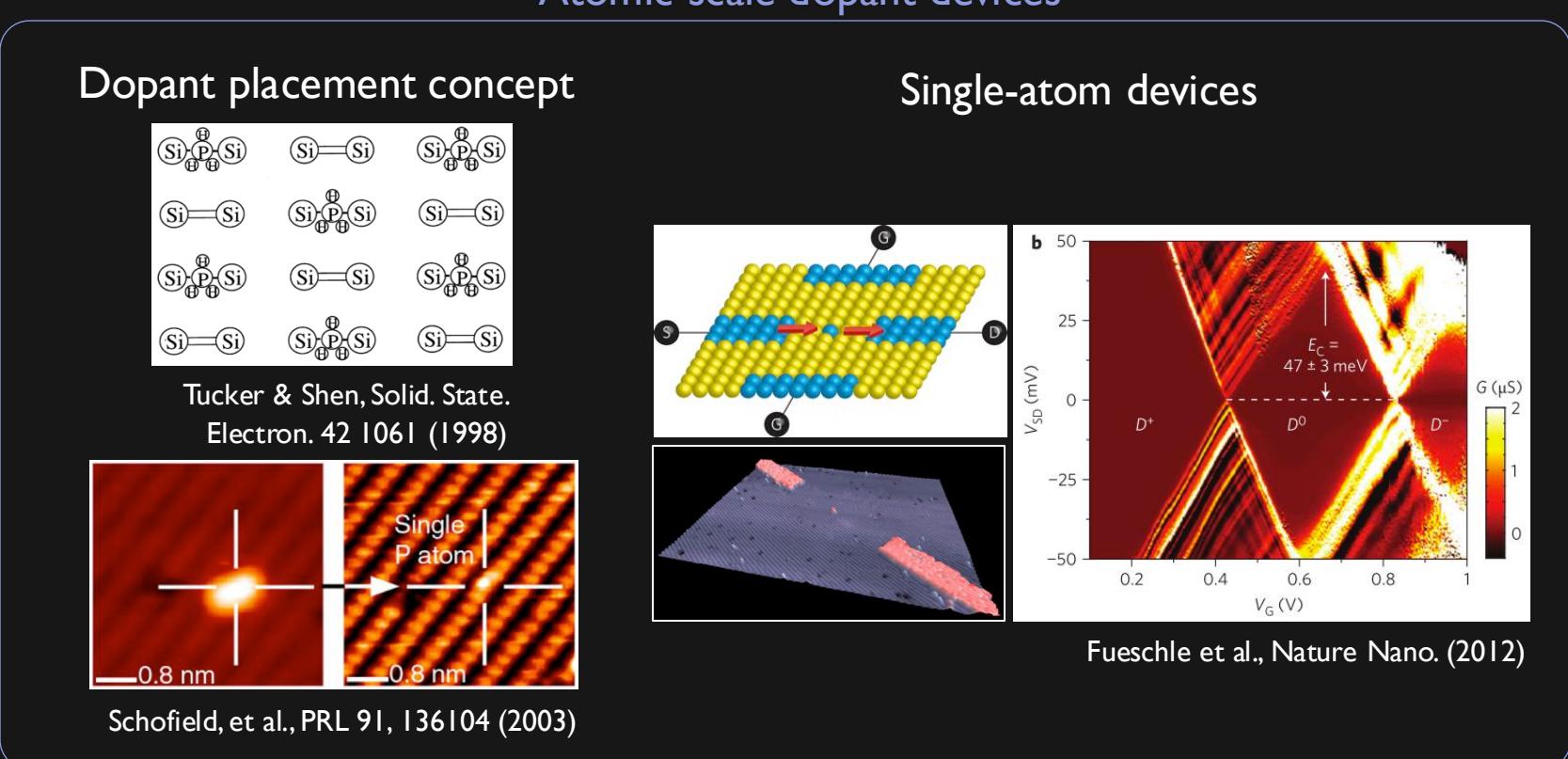
High Performance Computing



Fabrication strategy: atomic-scale dopant devices in semiconductors

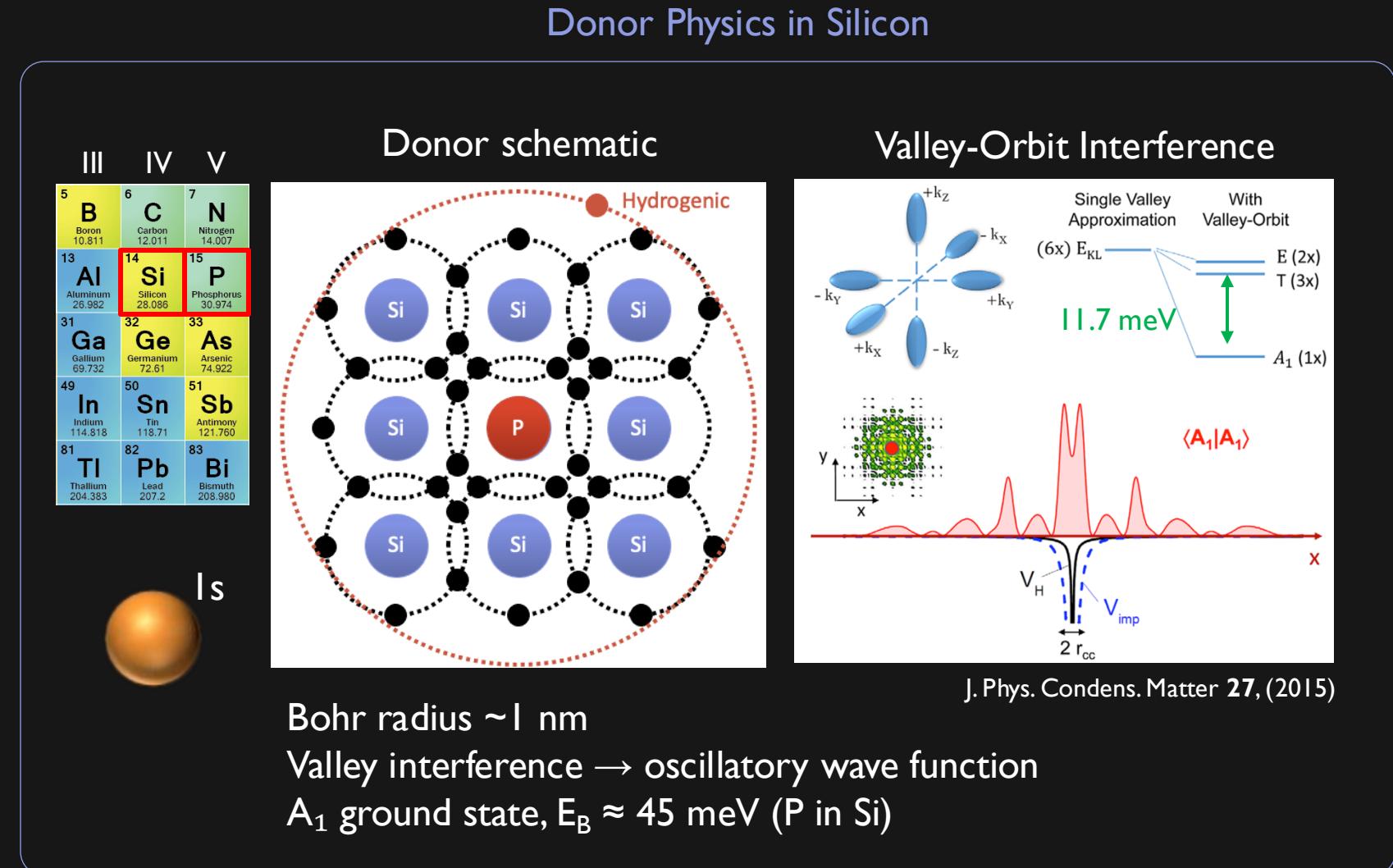


- Hydrogen terminated silicon patterned by STM
- Dopant precursors adsorb onto exposed silicon
- Annealing incorporates dopants; MBE overgrowth encapsulates them
- Single dopants first positioned in 2003
- Single-atom devices demonstrated (e.g., the single-atom transistor)



Group-V donors in Si behave like hydrogen: 1s, 2p, ...

- Substitutional group-V atoms in silicon (P, As, Sb, Bi) donate one electron which can be bound in hydrogen-like defect states, 1s, 2p, ...
- Valley–orbit coupling lifts the six-fold degeneracy
→ unique A_1 ground state
- Binding energy and Bohr radius depend systematically on the donor species



Germanium for Atomic-Scale Quantum Technologies

Why Germanium?

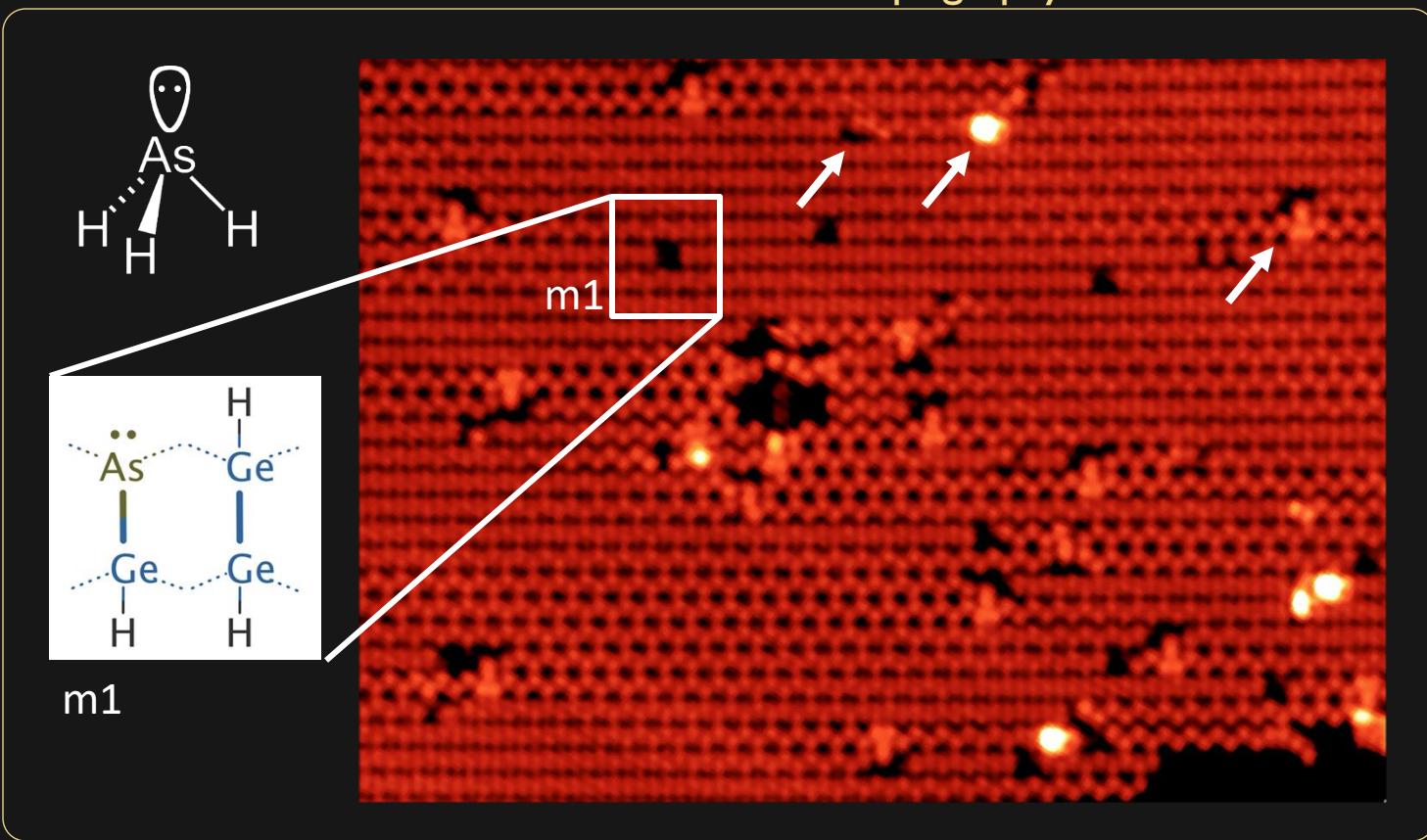
- Larger Bohr radius → wider qubit spacing
- Stronger Stark effect
- Reduced exchange oscillation sensitivity
- Long donor spin coherence times (\sim ms)
- Isotopically purified & industry compatible

	III	IV	V
5	Boron 10.811	6	Carbon 12.011
13	Aluminum 26.982	14	Silicon 28.086
31	Gallium 69.732	32	Germanium 72.61
49	Indium 114.818	50	Tin 118.71
		33	Arsenic 74.922
		51	Antimony 121.760

Why Arsenic?

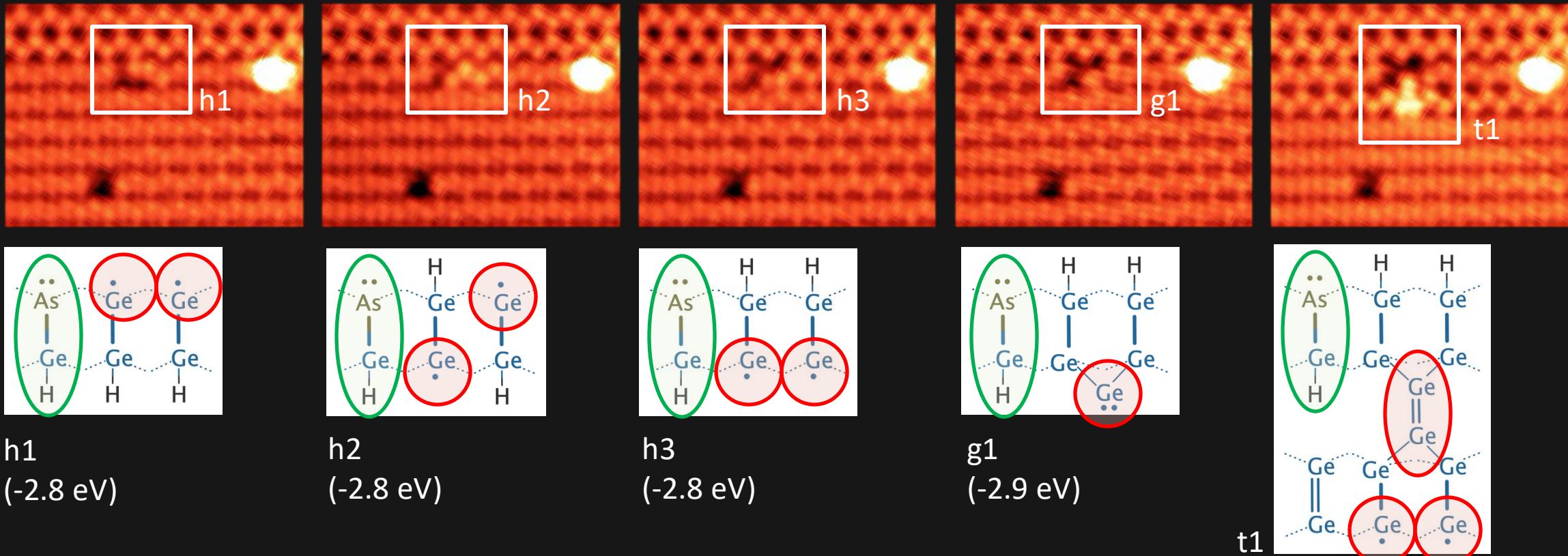
Arsine fully dissociates at room temperature on Ge(001), leading to As incorporation into the surface

Atomic-resolution STM topography



Dynamic behavior of features in STM data

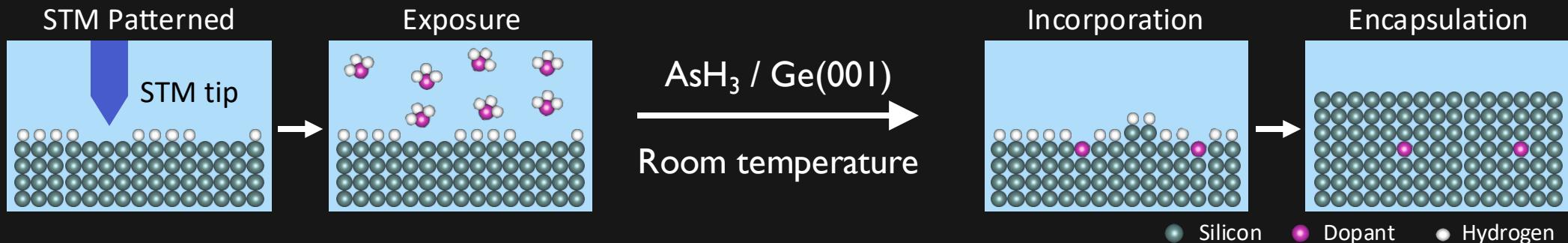
Structures are assigned based on their calculated stability, their appearance, and observed transitions.



Energies are from Gaussian 16 DFT calculations,
B3LYP, 6-311G++(2df,2pd), see manuscript for
details.

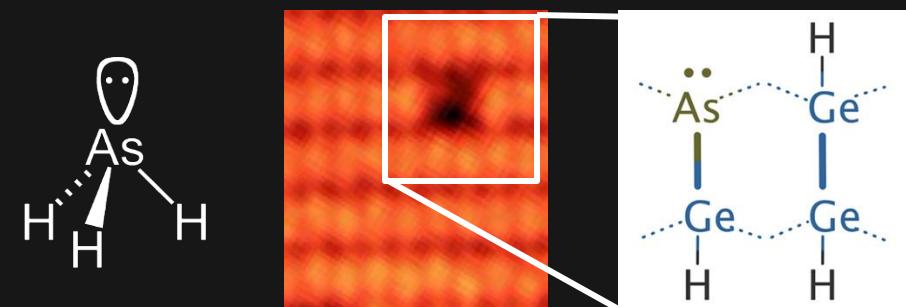
Hofmann, et al., Angewandte Chemie, 62, e202213982 (2023)

A New Surface-Chemistry Advantage for Germanium Quantum Technologies

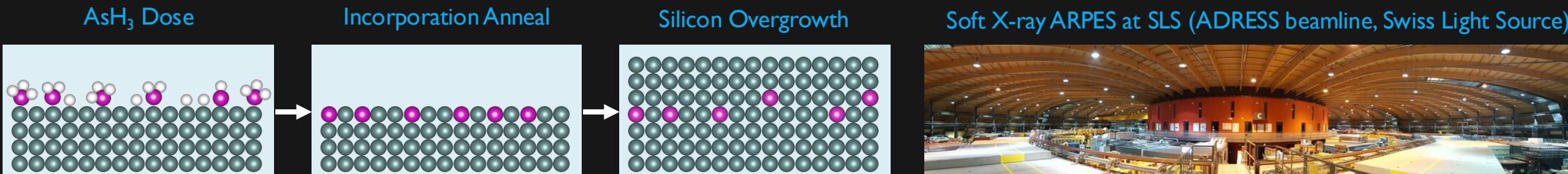


- Eliminating the incorporation anneal for arsenic in germanium compared to phosphorus in silicon removes a major obstacle to scaling deterministic donor arrays.
- This positions germanium as a compelling material platform for next-generation atomic-scale quantum technologies.
- Next steps: develop hydrogen-lithography methods to deterministically create the m1 incorporated structure.

Arsenic room temperature incorporation

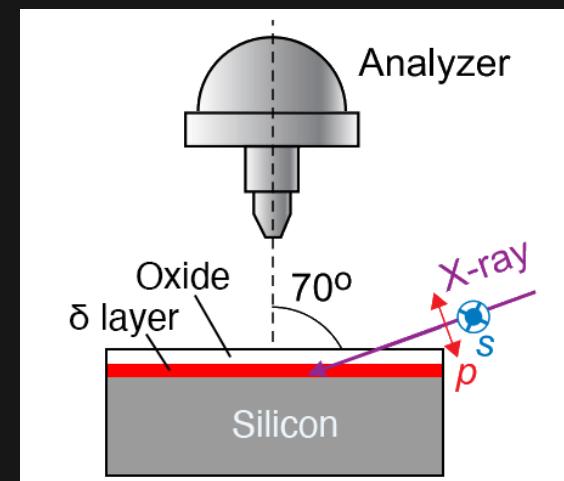
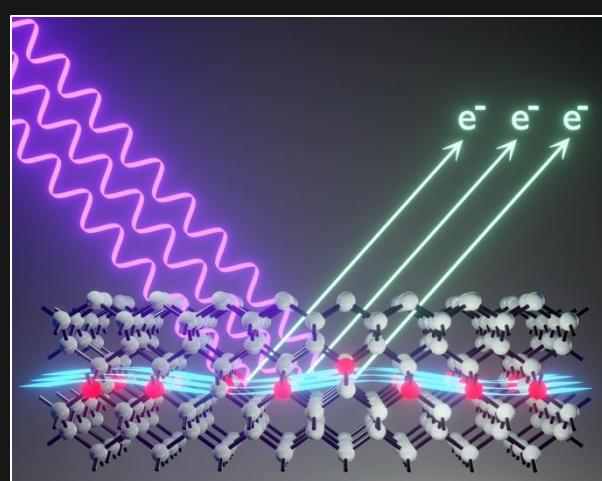


Electronic Structure of Atomic-Scale δ -Doped Layers Probed with SX-ARPES



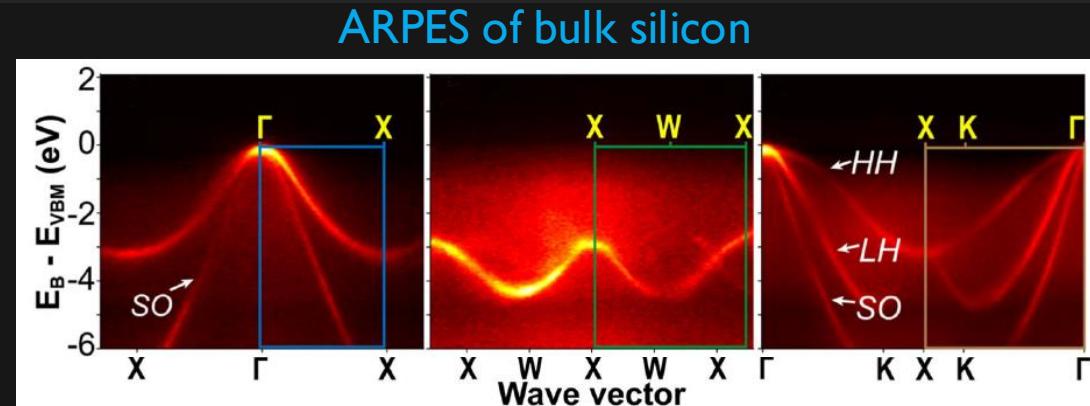
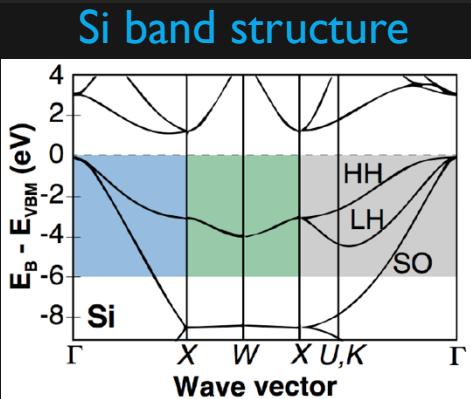
- δ -layers are atomic planes of dopants confined in crystalline silicon.
- δ -layers provide a pathway to 2D electron liquids with high densities (10^{14} cm^{-2}).
- SX-ARPES directly accesses the buried δ -layer's quantized sub-band structure and a way to measure their out-of-plane electronic thinness.

- Angle-resolved photoelectron spectroscopy (ARPES)
- Soft x-rays (300–820 eV) gives subsurface sensitivity (electron escape depth $\lambda_e \approx 2 \text{ nm}$).
- 12 K sample environment, 50–90 meV / 0.1° resolution. Spot size $\sim 10 \times 72 \mu\text{m}^2$.

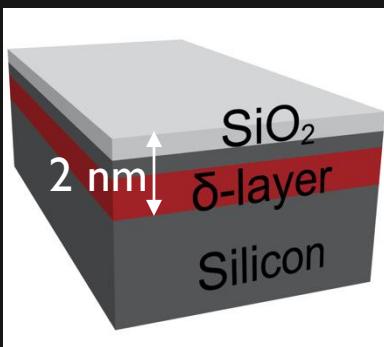


Resolving Quantum-Confinement States in δ -Doped Silicon with SX-ARPES

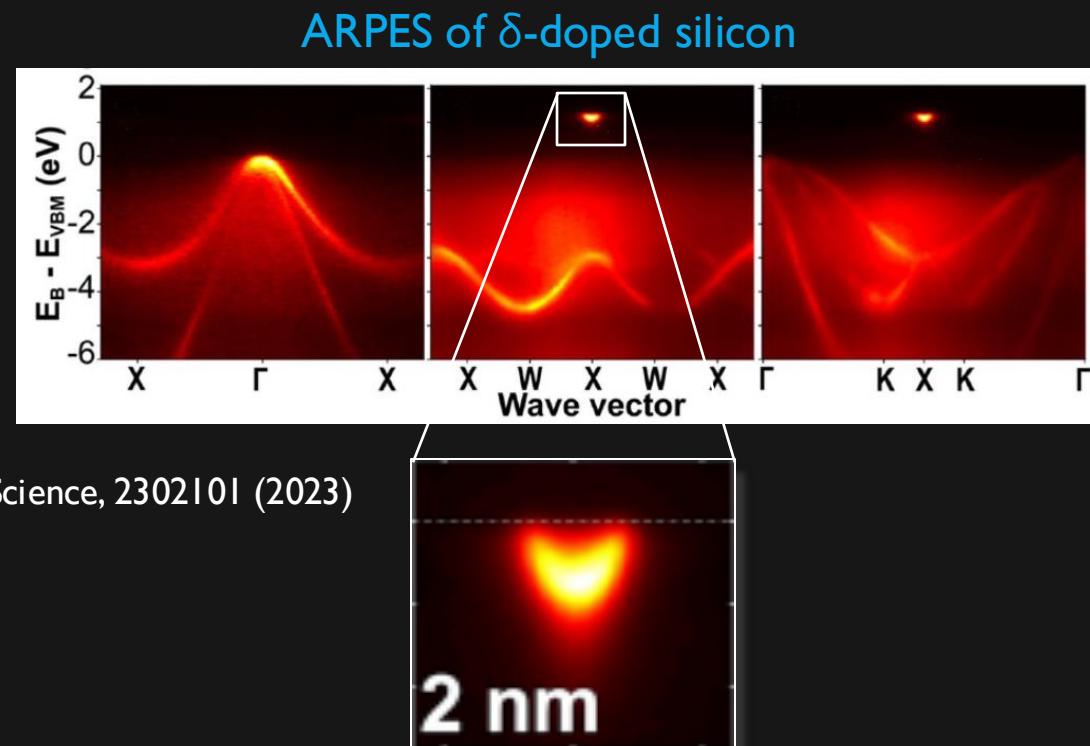
- Valence bands are well resolved, including heavy hole (HH), light hole (LH), and split-off (SO) bands.



- Fabricated an arsenic δ -layer with 2 nm Si overgrowth.
- The δ -layer donor band pockets appear near the conduction-band minimum close to the X points in the spectra.
- Quantum confinement in the δ -layer produces discrete subbands at the CBM.

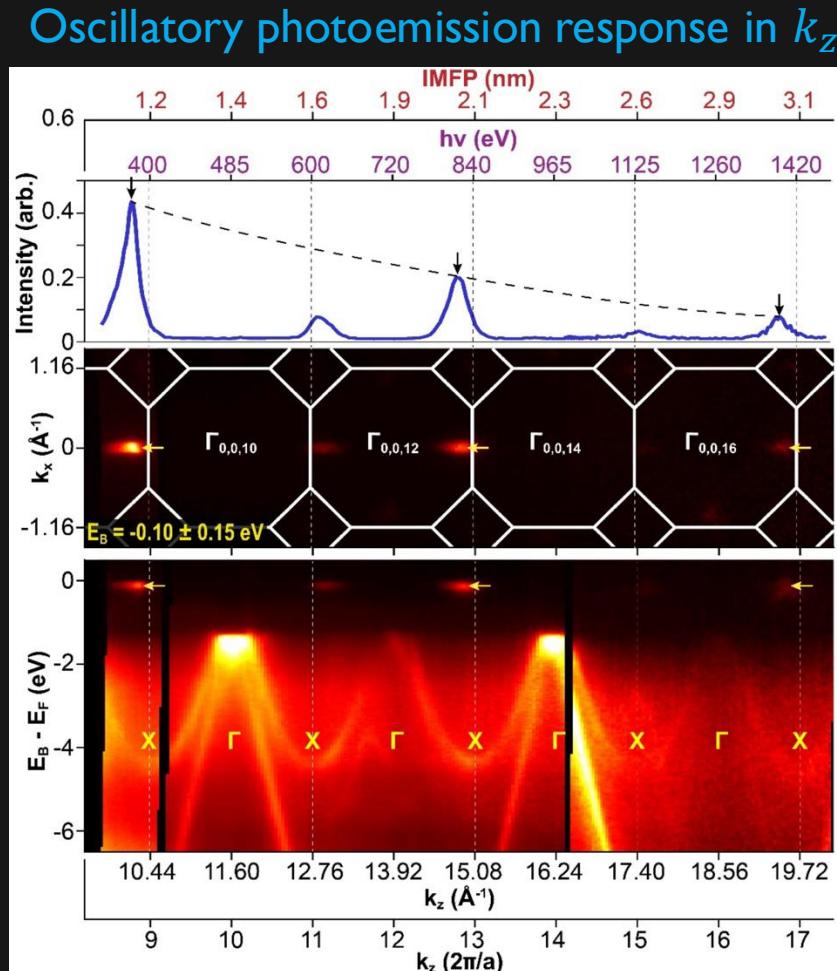


Constantinou et al., Advanced Science, 2302101 (2023)



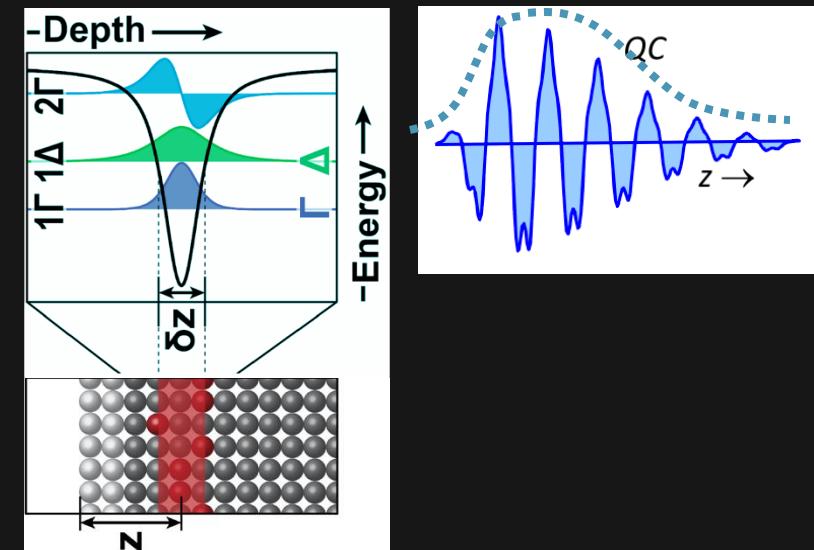
Oscillating photoemission intensity in k_z for the δ layer state

- δ -layer confinement produces a 1D envelope function in z , modulated by an oscillatory Bloch component.
- The interference between the envelope and Bloch components produces a photon-energy-dependent oscillation in k_z .
- The resonance width in k_z is inversely related to the envelope's spatial extent, providing a direct measure of the confinement length.

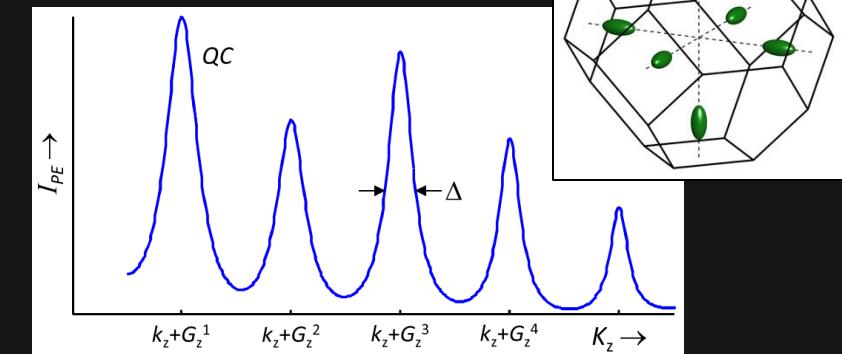


Constantinou et al., Advanced Science, 2302101 (2023)
Van Venrooij, et al., In preparation

δ -layer potential and wave function

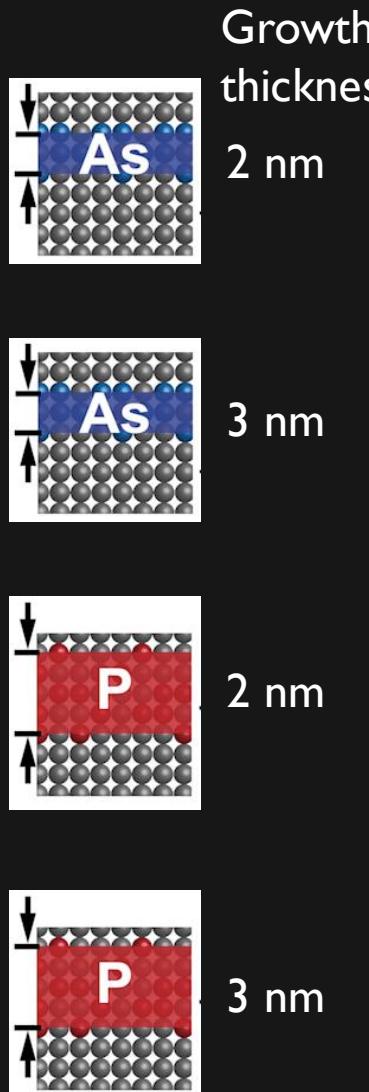
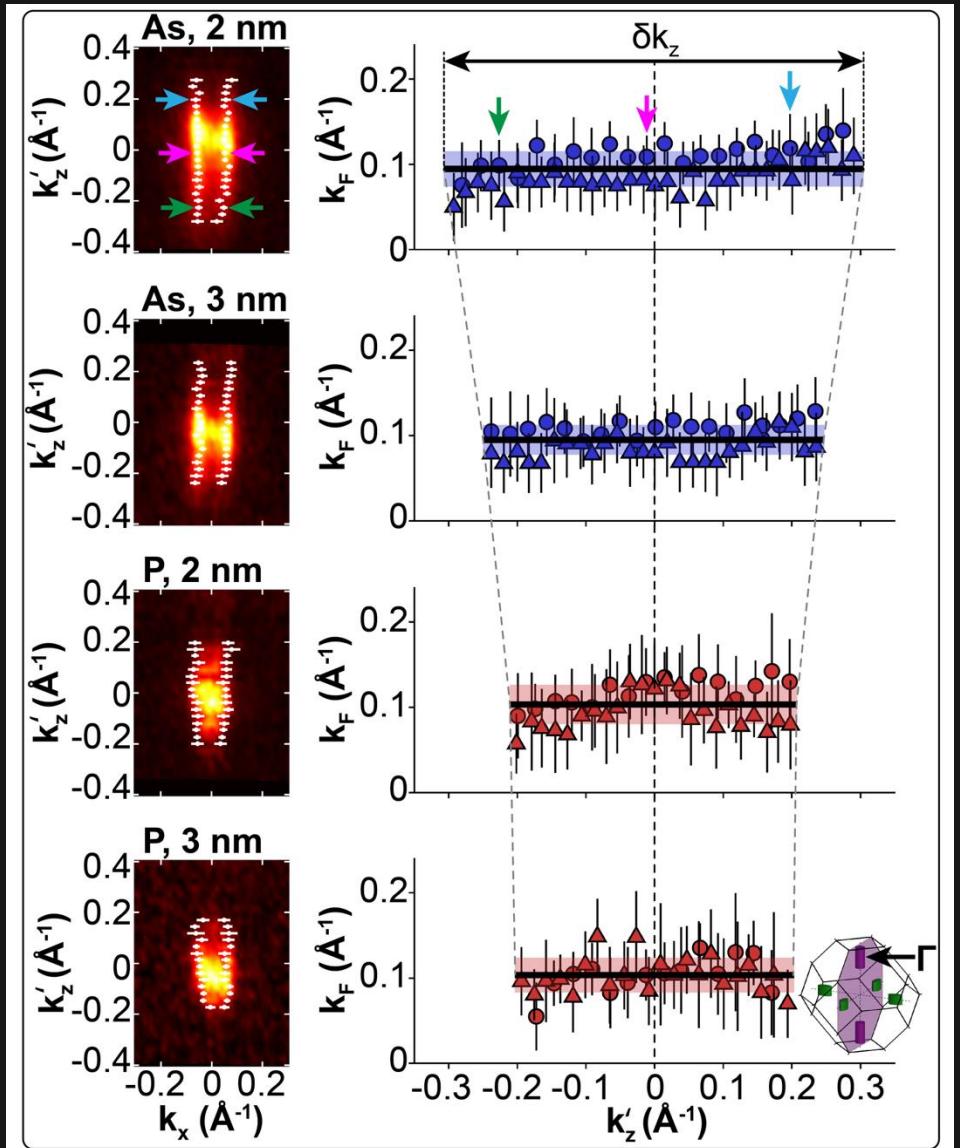


δ -layer Photoemission response and Brillouin Zone



J. Electron Spectrosc. Relat. Phenom. 229, 100 (2018)

Arsenic δ-layers Have Stronger Confinement than Phosphorus



- We fabricated P and As δ-layers with 2 nm and 3 nm Si overgrowth.
- The δ-layer width is extracted from the extent of the k_z valley in SX-ARPES.
- Arsenic δ-layers are more tightly confined than phosphorus δ-layers.
- The thinnest layer measured is 0.45 ± 0.04 nm – just over three atomic layers.

Overgrowth depth (left) versus δ-layer thickness (right)

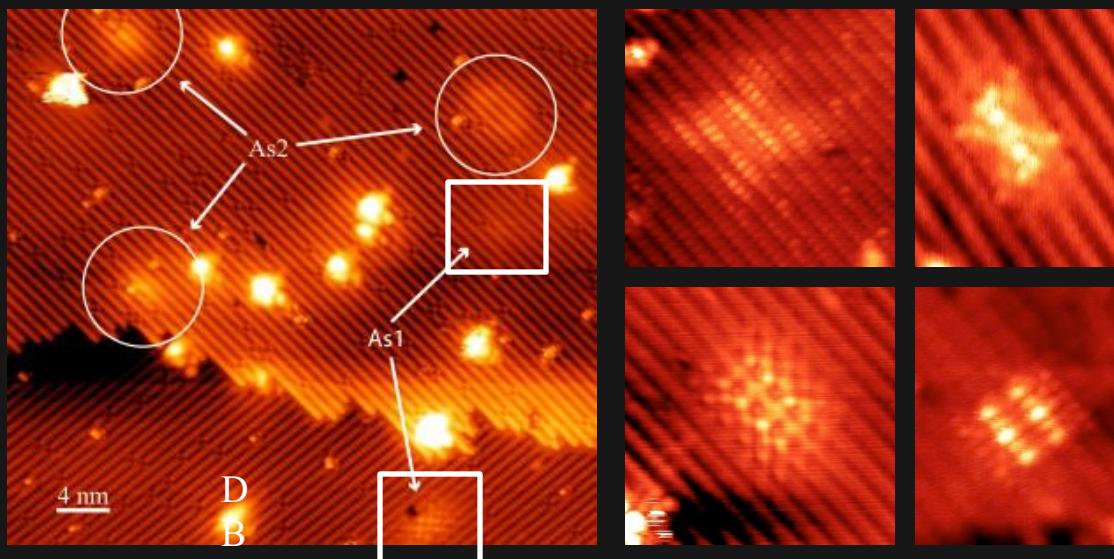
δ-layer species, depth	SX-ARPES (nm)
As, 2 nm	0.45 ± 0.04
As, 3 nm	0.62 ± 0.10
P, 2 nm	0.91 ± 0.21
P, 3 nm	1.03 ± 0.35

Constantinou et al., Advanced Science, 2302101 (2023)

Imaging Donor Wave Functions with STM: Arsenic in Silicon

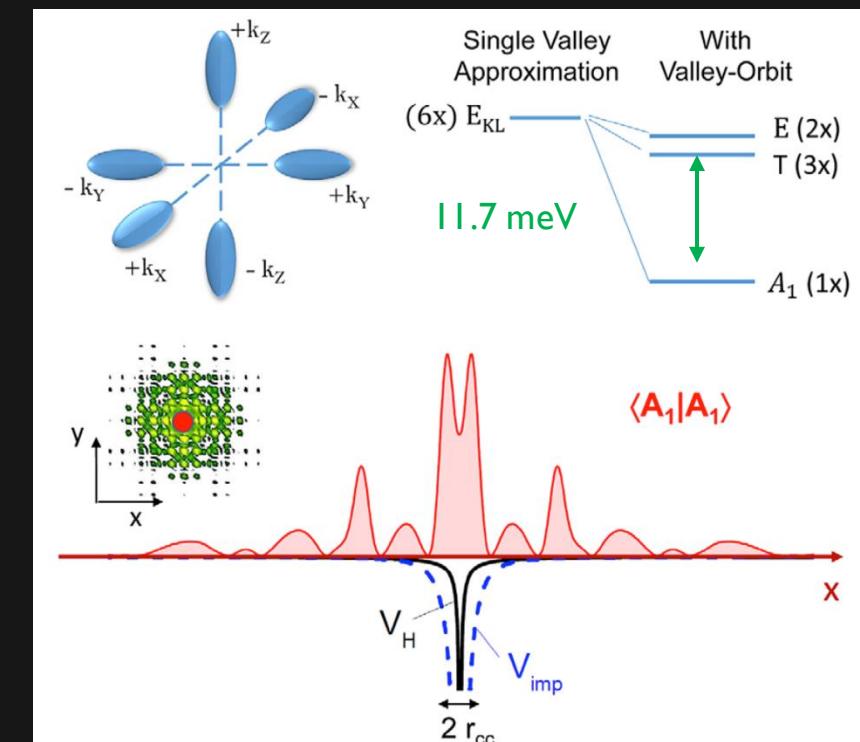
- Degenerately doped Si(001):As samples reveal subsurface donor wave functions with STM
- Samples must be prepared using a low thermal budget to preserve donors near the surface
- STM resolves both the 1s envelope and the Bloch-wave interference patterns of the donor states

STM Images of Arsenic Donors near H-terminated Si(001) (77 K)



The oscillatory features arise from interference between the six silicon conduction-band valleys (valley-orbit interference)

Valley-Orbit Interference



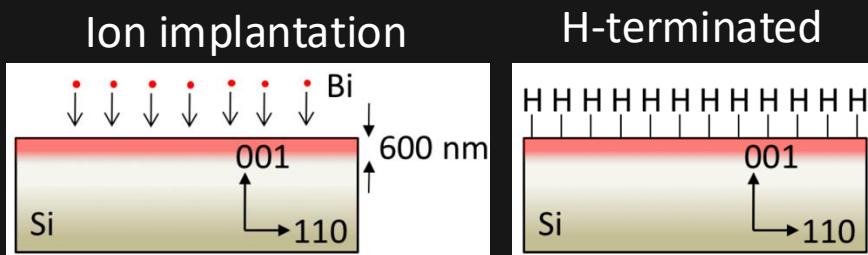
J. Phys. Condens. Matter 27, (2015)

Implanting Si(001) with bismuth

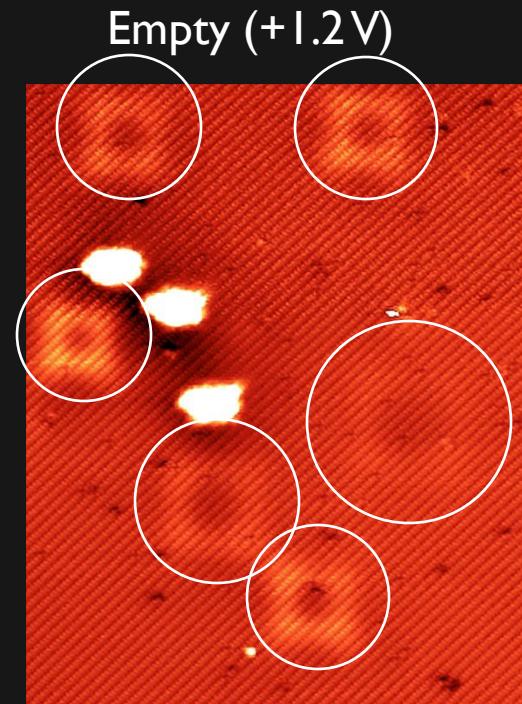
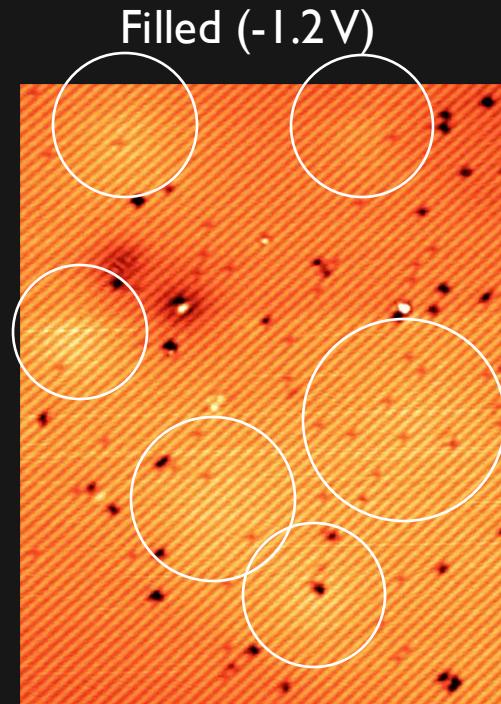
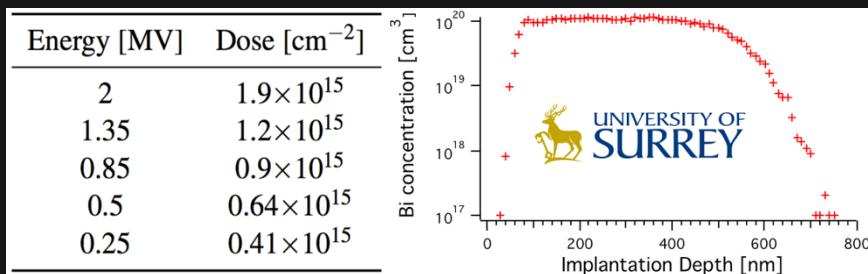
- Si(001) wafers implanted with bismuth to create high density of bismuth 20 – 600 nm below the surface.
- Samples were flash-annealed to 1050 °C in UHV and H-terminated for STM.
- STM reveals long-ranged features consistent with hydrogenic defect states

III	IV	V
5 B Boron 10.811	6 C Carbon 12.011	7 N Nitrogen 14.007
13 Al Aluminum 26.982	14 Si Silicon 28.086	15 P Phosphorus 30.974
31 Ga Gallium 69.732	32 Ge Germanium 72.81	33 As Arsenic 74.922
49 In Indium 114.818	50 Sn Tin 118.71	51 Sb Antimony 121.760
81 Tl Thallium 204.383	82 Pb Lead 207.2	83 Bi Bismuth 208.980

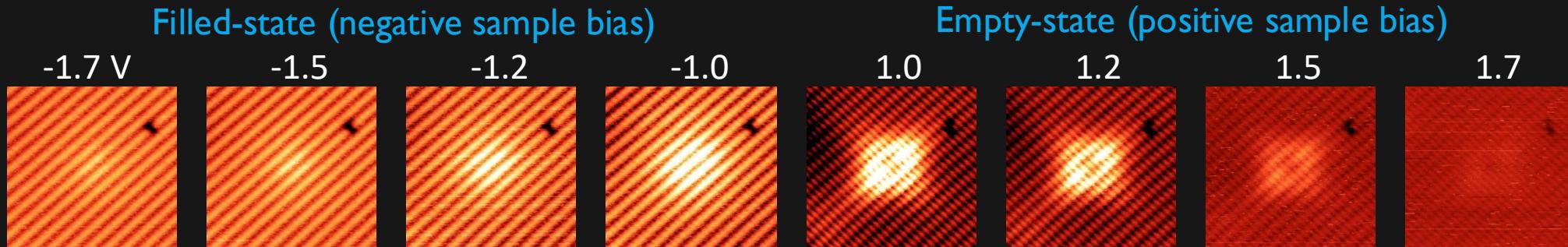
Sample fabrication: bismuth implantation



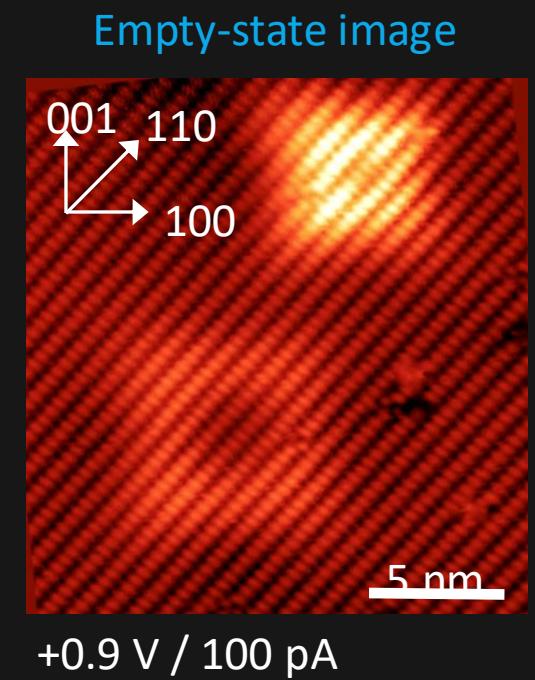
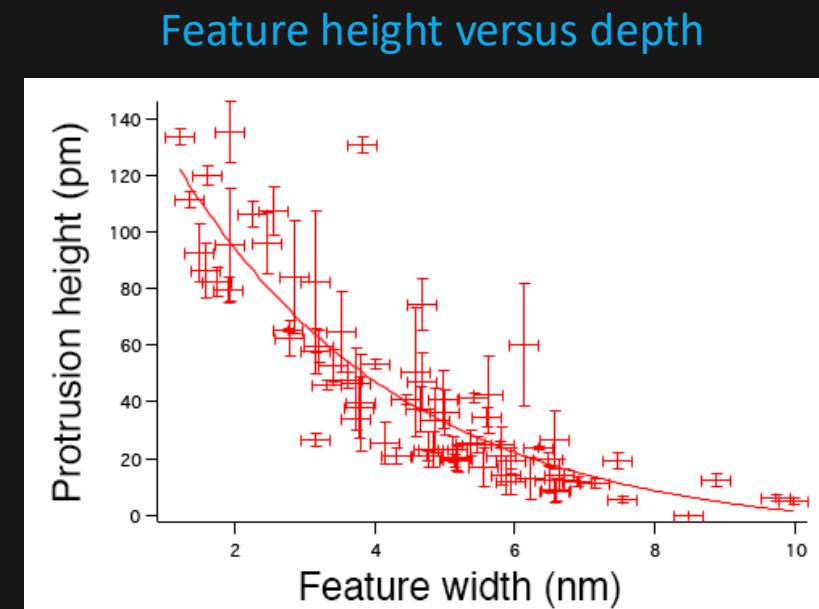
Bi ion implantation doses and profile (SRIM)



Appearance: bias dependence

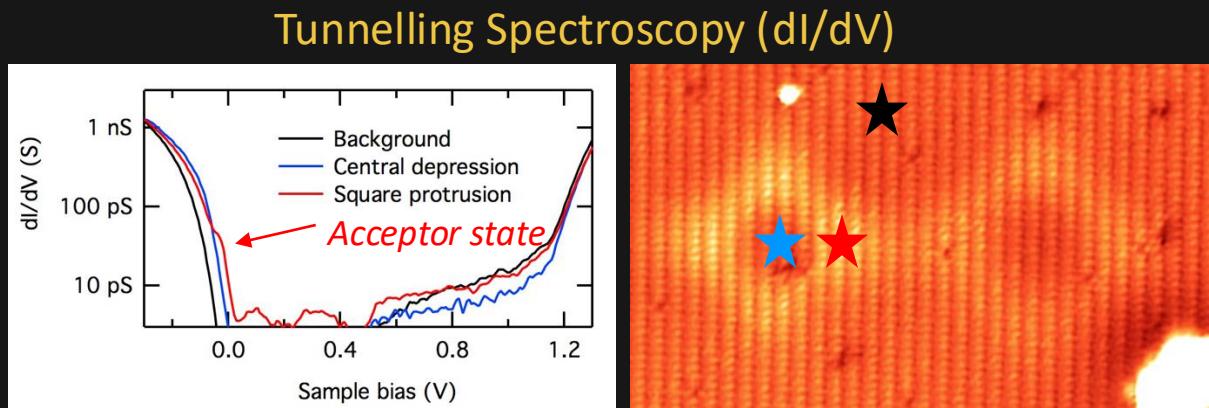


- In filled-state images the features appear as isotropic protrusions, whereas in empty-state images they develop a characteristic square anisotropy.
- They do not vary bias (other than in intensity) ruling out origins like quasiparticle interference
- We observe a range of correlated feature widths and intensities, consistent with defects at different depths within the substrate

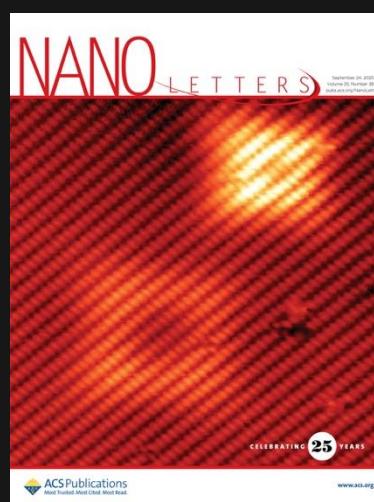


Identifying Acceptor States in Bi-Implanted Silicon

- Surface becomes p-type after Bi implantation.
- STM features lack the characteristic valley-orbit interference expected for donor states.
- Together, these observations show the states are
- Effective-mass and tight-binding calculations (Flatté group) independently confirm the features are acceptors, not donors.

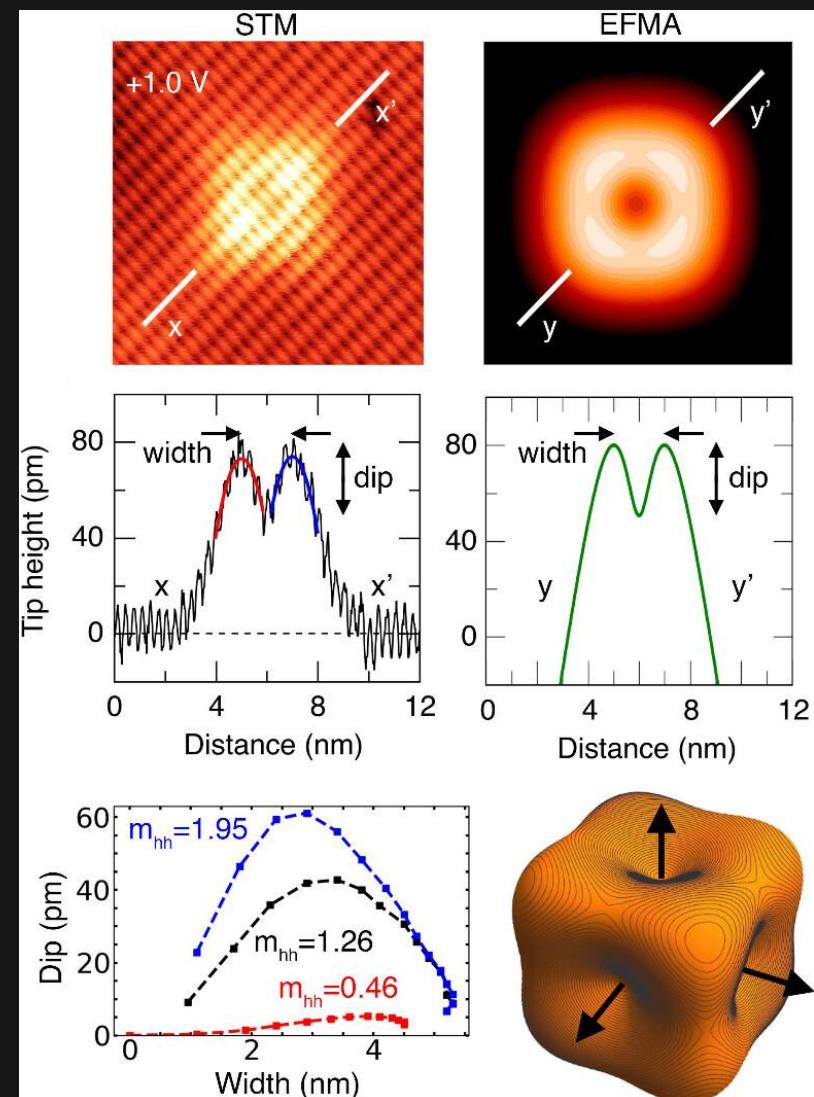


Bismuth implantation produced acceptor-like states rather than donors.



Nano Lett. 2025, 25, 38, 13996

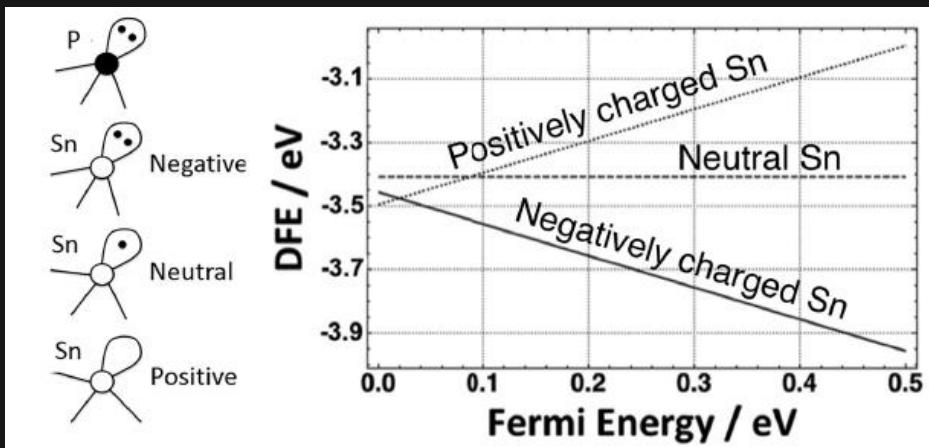
Acceptor wave-function modelling matches the experimental STM data



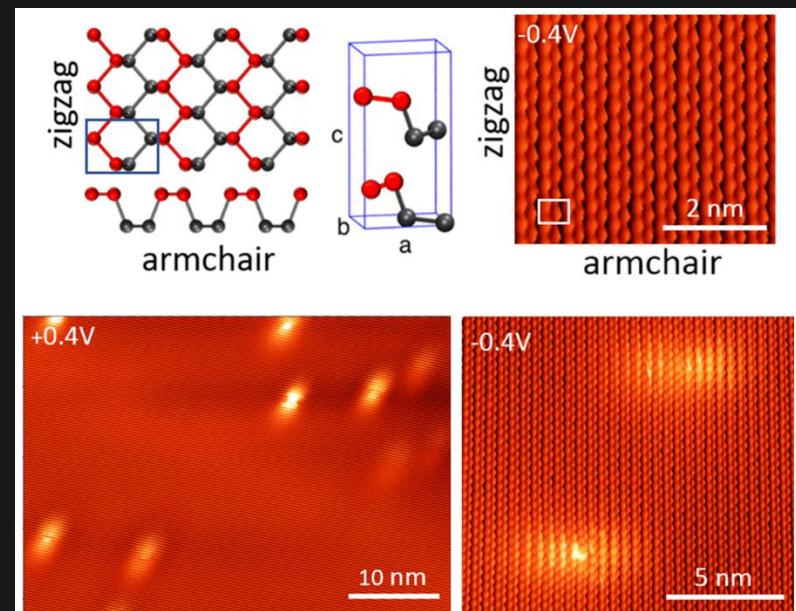
Electronic Defects in Black Phosphorus Revealed by STM

- Nominally pure black phosphorus behaves as a p-type semiconductor.
- This points to a ubiquitous presence of intrinsic defects.
- Using STM, STS, XPS, DFT, and tight-binding, we identify substitutional Sn impurities.
- These defects are negatively charged over a wide Fermi-level range, producing hydrogenic in-gap states.

DFT defect charge stability

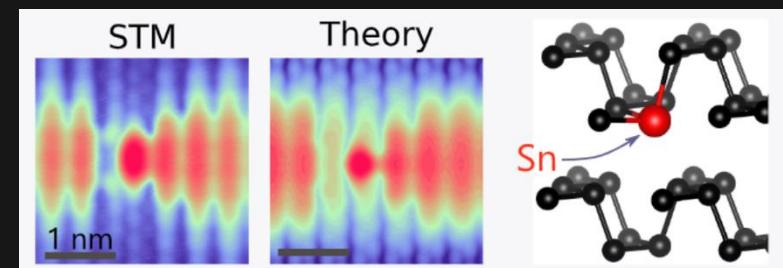


STM of Black Phosphorus



Wentink, et al., J. Phys. Chem. C, 125, 22883, 2021

Substitutional Sn defect: STM vs theory



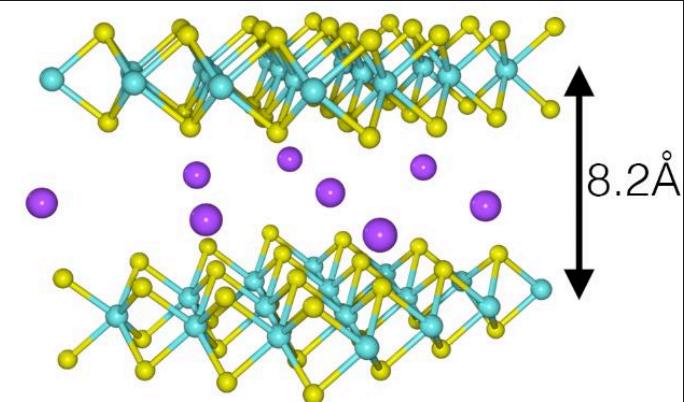
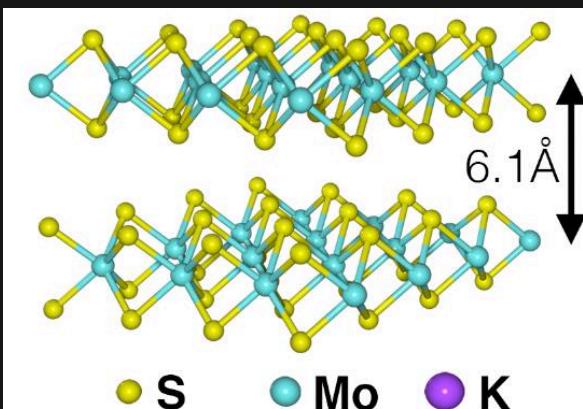
Harsh, et al., J. Phys. Chem. Lett., 13, 6276, 2022

Black phosphorus is inherently defect-rich, and substitutional Sn donors dominate its electronic character.

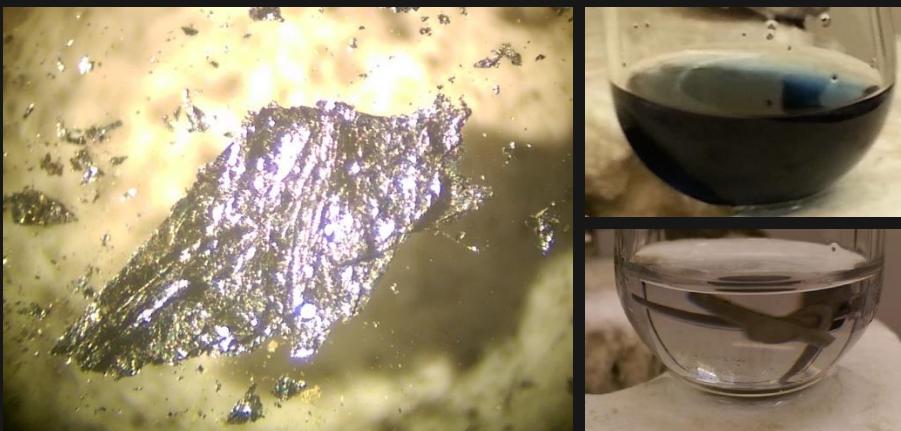
Electron doping via potassium intercalation: $K_{0.4}MoS_2$

- Intercalate potassium ions into the Van der Waals gaps using liquid ammonia.
- Intercalation completes at stoichiometry $K_{0.4}MoS_2$ after ~ 24 hours.
- Extremely high doping density: $4 \times 10^{14} \text{ cm}^2$
- XRD confirms the expected 35% increase in layer separation ($2.2 \pm 0.1 \text{ \AA}$).

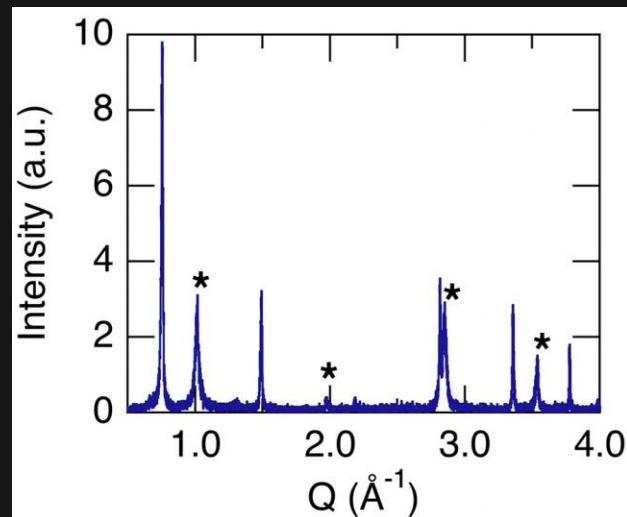
K intercalation in the VDW gaps



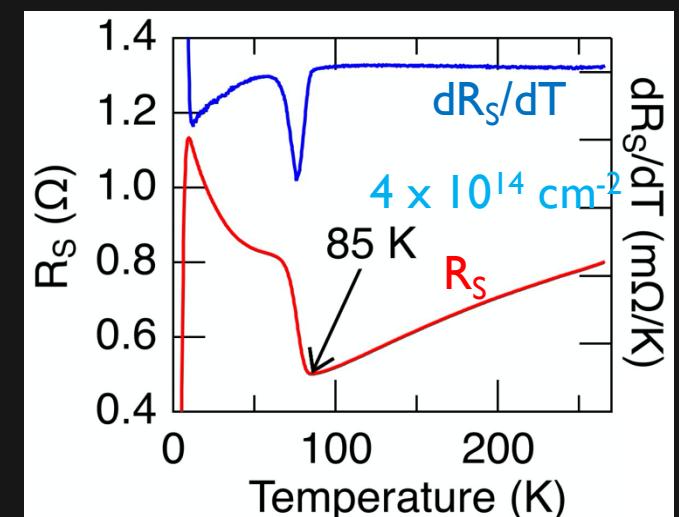
Intercalation of K using liquid ammonia



X-ray diffraction



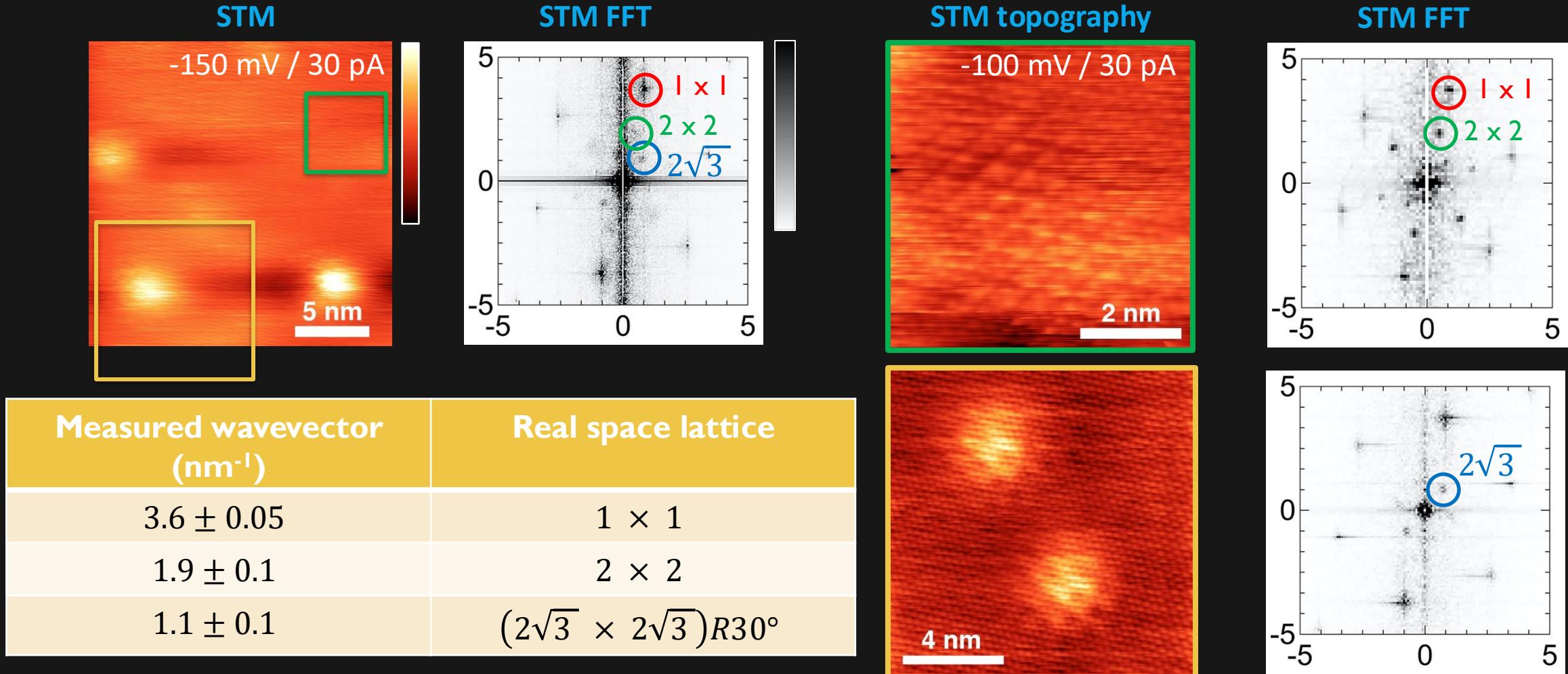
Resistivity with temperature



Bin Subhan, et al., Nano Lett., 21, 5516, 2021

$K_{0.4}MoS_2$: additional periodicity at defect sites

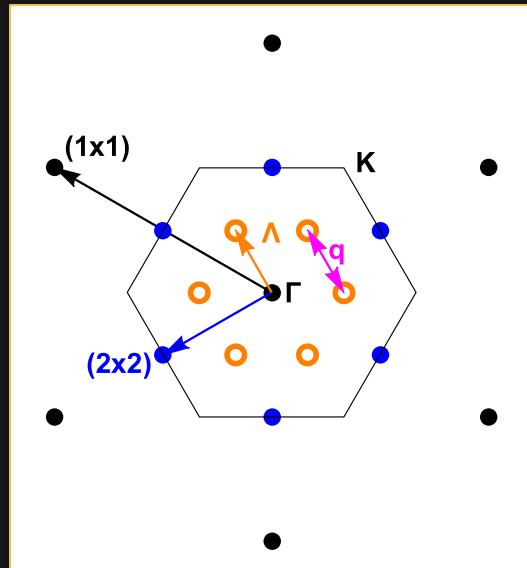
- We observe a (2×2) modulation across the material, consistent with a CDW predicted by DFT.
- Closer inspection of the defect sites reveals a $(2\sqrt{3} \times 2\sqrt{3})R30^\circ$ periodicity at these sites.



Bin Subhan, et al., Nano Lett., 21, 5516, 2021

Origin of the charge density waves

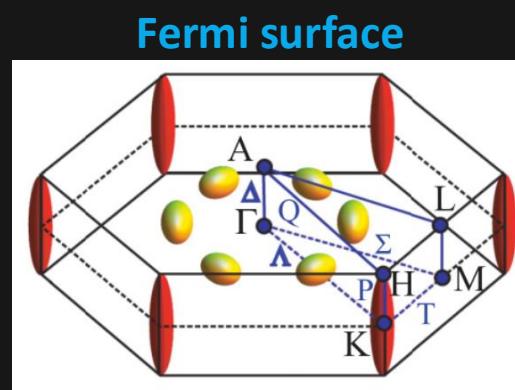
- The conduction band minimum lies midway along the Γ -K direction for bulk MoS₂.
- For monolayer undoped material the CBM is at the K point.
- Doping changes the balance again toward the bulk CBM.
- Defects are also known to increase inter-layer coupling.
- Fermi-surface nesting (FSN) at the bulk CBM has the correct wavelength for the observed $2\sqrt{3}$ modulation.



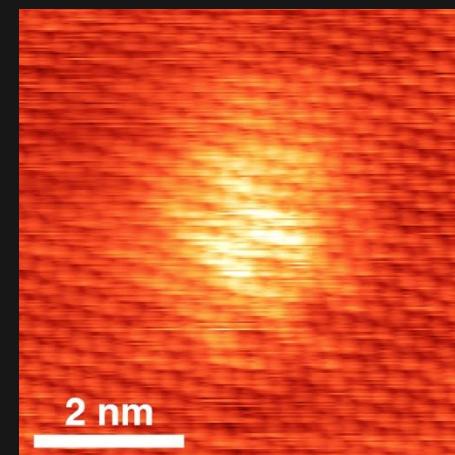
Measured wavevector (nm ⁻¹)	Real space lattice
1.1 ± 0.1	$(2\sqrt{3} \times 2\sqrt{3})R30^\circ$

$$|\Gamma K| = \frac{4\pi}{3a} = 13.26 \text{ rad nm}^{-1} = 2.11 \text{ nm}^{-1}$$

$$|\Gamma \Lambda| \sim \frac{|\Gamma K|}{2} = \frac{2\pi}{3a} = 6.63 \text{ rad nm}^{-1} = 1.05 \text{ nm}^{-1}$$



Peelaers et al. PRB 86, 241401(R) (2012)

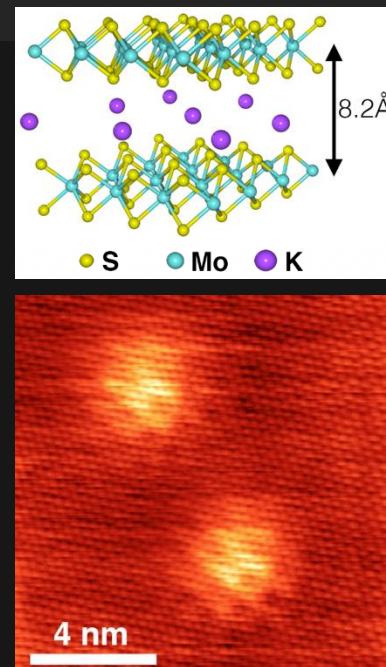


Bin Subhan, et al., Nano Lett., 21, 5516, 2021

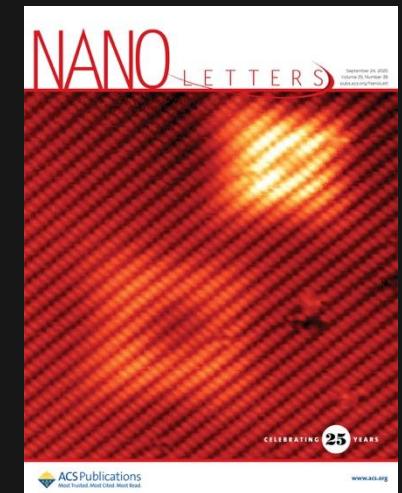
Summary

- We study the atomic-scale physics of semiconductors and 2D materials, focusing primarily on dopants and defects
- Using a complementary toolset we probe, image, and manipulate electronic states with single-atom resolution
 - STM/STS, SX-ARPES, XPS, and DFT/effective mass/tight-binding
- These methods enable us to fabricate and characterise δ -doped layers, directly image donor and acceptor wave functions, and identify intrinsic defects in materials such as black phosphorus and MoS₂
- Overall, this research provides microscopic understanding essential for atomic-scale quantum devices and defect-engineered technologies.

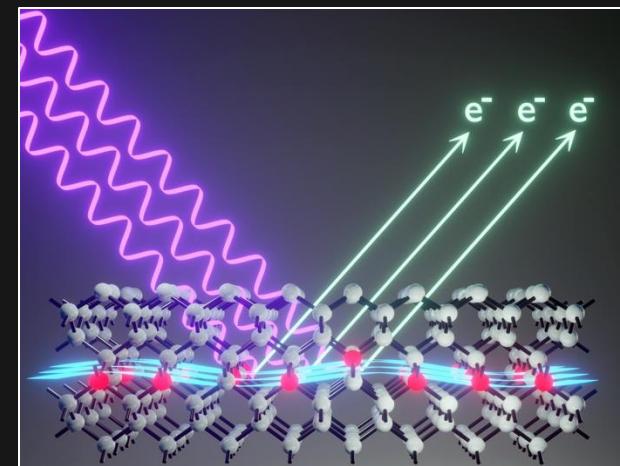
PhD studentships available, including: “Mapping the Quantum Landscape of 2D Materials, One Atom at a Time”



Nano Lett., 21, 5516, 2021



Nano Lett. 2025, 25, 38, 13996



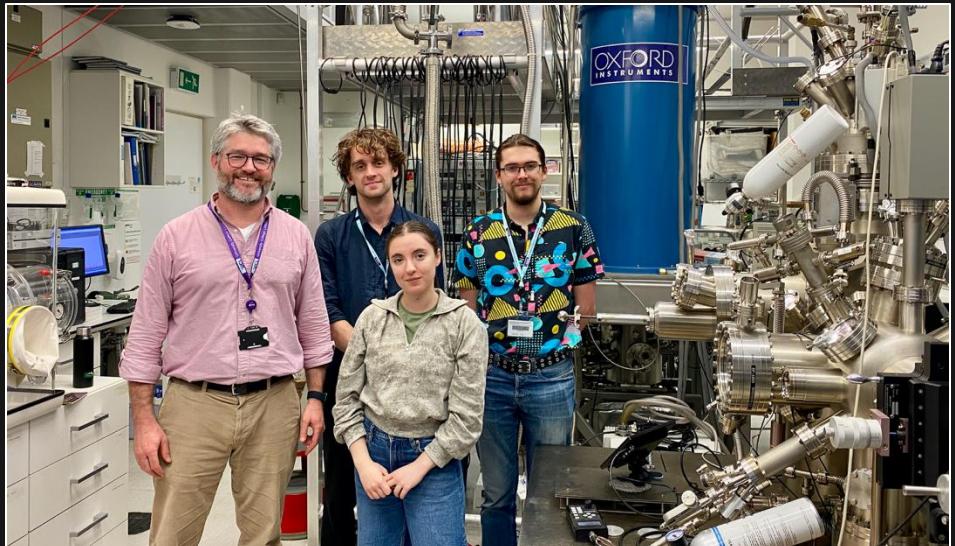
Constantinou, Advanced Science 10, 2302101 (2023)

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Students and postdocs who did most of the work:

- Emily Hofmann: Ge(001):AsH₃
- Procopi Constantinou: SX-ARPES Si δ-layers
- Kitiphat Sinthipharakoon: As donors in Si
- Manuel Siegl, Holly Hedgeland, Julian Zannon:
Acceptor states
- Mark Wentink: Black Phosphorus
- Kashim Subhan and Asif Suleman: K_{0.4}MoS₂

Current group members



Emily
Hofmann



Prokopios
Constantinou



Kitiphat
Sinthipharakoon



Manuel
Siegl



Holly
Hedgeland



Mark
Wentink



Kashim
Subhan



Asif
Suleman



Julian
Zannon
(Eindhoven)

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- Vladimir Strokov, Gabriel Aeppli (PSI)

EPSRC

Pioneering research
and skills